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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/050,334
Filing Date January 15, 2002
Inventor Vishnu K. Agarwal
Assignee Micron Technology, Inc.
Group Art Unit 2813
Examiner Tuan H. Nguyen
Attorney's Docket No. MI22-1913
Title: Capacitor Fabrication Methods and Capacitor Constructions and
Enhanced Surface

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to the United States patents and other references listed on the attached Form PTO-1449. No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 14 Feb 2006

By:


James E. Lake
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. MI22-1913		SERIAL NO. 10/050,334	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)					APPLICANT: Vishnu K. Agarwal			
					FILING DATE January 15, 2002		GROUP 2813	
U.S. PATENT DOCUMENTS								
Examiner's Initials		Document Number	Date	Name		Class	Subclass	Filing Date if Appropriate
	AA	2005/0082593 A1	04/2005	Lee et al.				
	AB	2003/0215960	11/2003	Mitsuhashi				
	AC	6,824,816	11/2004	Aaltonen et al.				
	AD	6,307,730	10/2001	Yamanishi				
	AE	6,800,892	10/2004	Bhattacharyya				
	AF							
	AG							
	AH							
	AI							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country		Class	Subclass	Translation
	AJ							Yes
	AK							No
	AL							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
	AN							
	AO							
EXAMINER		DATE CONSIDERED						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								